



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI**

Group Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND
SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**
Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 25, 2007

Sir:

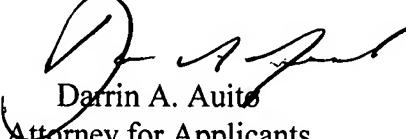
Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 4, 2007 for one month(s) from July 4, 2007 to August 4, 2007.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



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